\$2171

**PATENT** 

Attorney Docket No.: ITLV-00107

IN THE UNITED TO SEE PATENT AND TRADEMARK OFFICE

In re Application of:

Robert Olan Keith Jr.

Serial No.: 09/800,566

Filed: March 06, 2001

For:

METHOD AND APPARATUS FOR ACCESSING DATA WITHIN AN

JAN 0 8 2004

ELECTRONIC SYSTEM BY AN

EXTERNAL SYSTEM

Group Art Unit: 2171

Examiner: Nguyen, Cam Linh T.

TRANSMITTAL LETTER

162 N. Wolfe Road Sunnyvale, CA 94086 (408) 530-9700 RECEIVED

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Customer No. 28960

Technology Center 2100

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Enclosed please find an Supplemental Information Disclosure Statement, Form PTO-1449, including copies of the references contained thereon, and a check in the amount of \$180.00 for filing in the U.S. Patent and Trademark Office.

The Commissioner is hereby authorized to charge any additional fee or credit overpayment to our Deposit Account No. <u>08-1275</u>. An originally executed duplicate of this transmittal is enclosed for this purpose.

Respectfully submitted,

HAVERSTOCK & OWENS LI

Dated: January 6,2004

Jonathan O. Owens

Reg. No.: 37,902

RECEIVE Applicant

JAN 21 REC'D

TC 2100

CERTIFICATE OF MAILING (37 CFR§ 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

HAVERSTOCK & OWENS LLP:

Date: 1-6-04 By

- 1 -



Attorney Docket No.: ITL

## HE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2171 Robert Olan Keith, Jr. Serial No.: 09/800,566 Filed: March 6, 2001 For: METHOD AND APPARATUS FOR ACCESSING DATA WITHIN AN ELECTRONIC SYSTEM BY AN EXTERNAL SYSTEM

Examiner: Nguyen, Cam Linh T.

**SUPPLEMENTAL INFORMATION** DISCLOSURE STATEMENT

162 N. Wolfe Road Sunnyvale, CA 94086 (408) 530-9700

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Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

In re Application of:

**Technology Center 2100** 

Sir:

The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

Applicant has become aware of the following printed publications which may be material to the examination of this application:

- U.S. Patent No. 6,185,569 B1;
- U.S. Patent Application No. 2002/0023085 A1;
- U.S. Patent Application No. 2002/0091686 A1;
- U.S. Patent Application No. 2002/0032672 A1;
- U.S. Patent Application No. 2001/0025304 A1;
- U.S. Patent Application No. 2002/0016793 A1;
- U.S. Patent Application No. 2002/0065812 A1; and
- U.S. Patent Application No.2002/0004793 A1.

PATENT Attorney Docket No.: <u>ITLV-00107</u>

This Supplemental Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: January 6, 2004

Jonathan O. Owens Reg. No.: 37,902

Attorneys for Applicant

CERTIFICATE OF MAILING (37 CFR§ 1.8(a))

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